

Application/Control No.	Applicant(s)/Patent under Reexamination
10/826,799	DEPUE ET AL.
Examiner	Art Unit
David L. Lewis	2629

SEARCHED					
Class	Subclass	Date	Examiner		
345	156-179	1/20/2008	DL		
356	3.01	1/20/2008	DL		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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